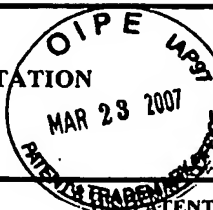


# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

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Applicant(s)

Takemasa Yasukawa

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2823

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/B.K./	1	US 6,680,568 B2	01/20/2004	Fujiwara et al.			

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/B.K./	2	US 2002/0105266 A1	08/08/2002	Juestel et al.			

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/B.K./	3	CN 1366714 A	02/11/2005	CHINA				✓
/B.K./	4	CN 1349262 A		CHINA				✓

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

/B.K./		Chinese Office Action dated February 2, 2007 with partial English translation.

EXAMINER	/Brook Kebede/	DATE CONSIDERED	04/19/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.